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	Filing Date		2005-09-26		
	First Named Inventor	Micha	lichael Baentsch		
	Art Unit		2431		
	Examiner Name	Matth	ew T. Henning		
	Attorney Docket Numb	er	CH920020034US1		

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	2	PCT/FI1998/000761	FI			1999-01-04	Lassi Hippelainen	See Abstract			
	3	PCT/FR2000/000412	FR			2000-08-24	Jean-Claude Paille	s	See Abstract		

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	4	PCT/	US2000/020151	us		2001-02-08		even R. Hoffman, zanne C. Cutino	See Abstract	
	5	PCT/I	IB2001/001462	IB		2002-03-14		darajah Asokan, Philip nzboorg	See Abstract	
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